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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OFFICIAL

In re: Armbrust et al

Examiner: D. Kang

Serial No.: 09/666,325

Group Art Unit: 2811

Filing Date: September 21, 2000

Title: Self-Aligned Copper Silicide Formation  
For Improved Adhesion/Electromigration

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REPLY AND AMENDMENT  
UNDER 37 C.F.R. §1.11

In reply to the Office Action mailed December 29, 2003, Applicants respectfully request reconsideration of the outstanding rejections and reexamination of the present application in light of the following remarks and amendments.

CERTIFICATE OF TRANSMISSION UNDER 37 CFR 1.8

I certify that this correspondence of 8 pages is being transmitted by facsimile to the United States Patent and Trademark Office to: Examiner D. Kang, Art Unit 2811 at facsimile number 703 872-9306 on March 23, 2004 by Arnette Dodge

Annette Dodge  
(Signature of person transmitting paper)

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